

#2
2/4/02

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masayuki SAITO

Group Art Unit: Unknown

Application No.: Not Yet Assigned

Examiner: Unknown

Filed: Concurrently Herewith

Attorney Dkt. No.: 108384-00005

For: LOW-PRESSURE CVD APPARATUS AND METHOD OF MANUFACTURING A THIN FILM

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Date: December 4, 2001

Sir:

Prior to initial examination of the application, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend the specification by inserting before the first line the sentence--

This nonprovisional application claims the benefit of U.S. Provisional Application No. 60/254,193, filed December 11, 2000.

IN THE CLAIMS:

Please amend claims 3-8 as follows:

3. (Amended) The LPCVD apparatus according to claim 1, wherein the honeycomb-structure cylindrical fillers have holes with a maximum diameter of 0.5 to 10 mm.